Geometries and Fabrication Processes for High-Performance Nano-Granular Magnetics on Silicon

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Required for magnetics success

- Good materials: copper and ?
- Geometry selection
- Good models: faster than 3D FEA
- Design optimization: target system efficiency and power density not arbitrary inductor specs
- Fabrication process
- Measurements
- Reliability
- Low cost



All are important but only items in red discussed in this talk

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Two types of inductors

Pot-core



Core wraps winding

Toroidal



Winding wraps core

Many intermediate geometries are also possible

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Inductors on Si





Two magnetic depositions
One magnetic deposition.

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Ceramic (Al₂O₃, ZrO₂, etc.)

Advantages:

- Ferromagnetic (coupled particles)
- High resistivity (300 ~ 600 µΩ·cm) controls eddycurrent loss independent of flux direction.
- Some have strong anisotropy for low permeability and low hysteresis loss.



TEM of multilayer nanogranular film





Permeabilty vs. frequency



Magnetic anisotropy: common in thin-film magnetic materials

Hard axis loop provides:



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Microfabricated inductors



- Two magnetic depositions
- Uses magnetic material only in hard axis

 Does not work with uniaxial anisotropy



Applying anisotropic materials in microfabricated magnetics



- Racetrack for multi-turn high-Z;
- V-groove for single-turn low-Z.
- Material oriented by field applied during deposition







Fabrication Steps 1-7 of 11

- Mostly standard processes.
- Reactive sputtering of Co-Zr-O magnetic material.
 - Shadow mask or wet etching





Fabrication Last 3 steps

Sloping sidewalls on top insulator achieved with prism-assisted UV-LED lithography.





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Racetrack inductors fabricated at Dartmouth



Performance in 100 V to 35 V converter and comparison to other some other work:





Flux crossing magnetic laminations

- Problem in corners where top and bottom magnetic core halves join.
- Excess eddy currents limit efficiency and Q.
- Power loss, due to out-of-plane flux (OOPF): P_{OOPF}.





Variations on the theme: Other designs with the same problem.

- V-groove 1-turn inductor for high current (up to 12 A)
- Polyimide substrate with sputtered material on both sides
- Microfabricated coupled inductors (2004, with Tyndall)









Toroidal Inductors: No out-of-plane flux! No P_{OOPF}!

- Advantage:
 - Flux stays in plane, minimizing eddy-current losses.
- Challenge:
 - Flux direction varies; sometimes oriented incorrectly for the magnetic material anisotropy.
- Solution:
 - Induced radial anisotropy, such that flux travel is always in the low-loss hard-axis direction.





Fixture to deposit toroidal cores with radial anisotropy





Qiu and Sullivan, CIPS, 2012

Fabricated array of fixtures



Co-Zr-O radial-anisotropy cores



Outer diameters: 5.5 mm Inner diameters: 1.7 mm, 2.3 mm, 3.4 mm Thickness: 6 µm, 40 µm

Permeability of radial-anisotropy cores





Permeability of radial-anisotropy cores with different thicknesses



| Outer diameter | Inner diameter | thickness | |
|-------------------|-------------------|-----------|--|
| 5.5 mm | 3.4 mm | 40 µm | |
| 5.5 mm | 3.4 mm | 6 µm | |

- Both cores show Q~100 at f < 100 MHz.
- Characteristics differ at f > 500 MHz:
 - The thicker core has a lower resonant frequency, presumably a selfresonance of the multi-layer structure.

Measured by Agilent test fixture



CoZrO core integrated inductor: Dartmouth cores integrated by Georgia Tech







Batch fabrication



- Cores were deposited on individual substrates, and manually dropped in windings at process mid-point.
- OK for a demonstration project, but can we do true batch fabrication?
 - Many on one substrate.
 - All processes on one substrate.
 - Avoid the need for a tiny magnet for each.







- Can make any number of radial-field regions with only two magnets.
- Can photo etch new top plate for a new design.

Process flow



Samples with dummy core





All four-turn inductors—lower winding design minimizes capacitance. See Jizheng Qiu, A.J. Hanson, C.R. Sullivan, "Design of toroidal inductors with multiple parallel foil windings" Control and Modeling for Power Electronics COMPEL 2013.

Summary



- Anisotropic nanocomposite magnetic materials can provide high performance at MHz frequencies.
- Design options for anisotropic materials include
 - Racetrack and similar geometries.
 - Toroids with radial anisotropy.
- Racetrack inductor performance proven in high-voltage dc-dc converters.
- Radial anisotropy proven in individual cores.
- Process proposed for batch fabrication of toroidal inductors.
- Other important topics not addressed here include modeling, design optimization, and measurement techniques.



Key references



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Anisotropic Co-Zr-O Thin Films Sputtering with external field



Magnetic material properties:

- High Resistivity: $300^{\circ}600 \ \mu\Omega cm$
- Relative permeability: 80~100
- High saturation flux density: 1.2 T
- Low coercivity: 4 Oe
- High in-plane anisotropy



Thin-film inductor geometries





| Closed core | Yes | Yes | No |
|--|-----|-----|-----|
| Core deposition steps | 2 | 1 | 1 |
| Magnetic vias | Yes | No | No |
| Compatible with uniaxial anisotropy | Yes | No | Yes |

Pictures from "Integrating Magnetics for on-Chip Power: A Perspective", C. R. Sullivan et al., IEEE trans on power electronics, 2013.